

Search Notes

Application/Control No.

10/660,306

Examiner

Christopher K. Agrawal

Applicant(s)/Patent under
Reexamination

LIU, HEBEN

Art Unit

3726

SEARCHED

Class	Subclass	Date	Examiner
29	890.032	1/11/2006	CKA
	890.046	1/11/2006	CKA
	890.05	1/11/2006	CKA

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
see attached EAST workspace for search history	1/11/2006	CKA
consulted Examiner Compton regarding field of search	1/11/2006	CKA